Absorption loss at nanorough silver back reflector of thin-film silicon solar cells

J. Springer,[a)] A. Poruba, L. Müllerova, and M. Vanecek
Institute of Physics, Academy of Sciences of the Czech Republic, Cukrovarnicka 10, CZ-16253, Prague 6, Czech Republic

O. Kluth and B. Rech
Institute of Photovoltaics, Forschungszentrum Jülich GmbH, D-52425 Jülich, Germany

Absorption losses at a nanorough silver back reflector of a solar cell were measured with high accuracy by photothermal deflection spectroscopy. Roughness was characterized by atomic force microscopy. The observed increase of absorption, compared to the smooth silver, was explained by the surface plasmon absorption. Two series of silver back reflectors (one covered with thin ZnO layer) were investigated and their absorption related to surface morphology. © *2004 American Institute of Physics.* [DOI: 10.1063/1.1633652]

I. INTRODUCTION

A rough silver back reflector is used in thin-film silicon solar cells to reflect and scatter light, which was not absorbed during the first path through the very thin solar cell. The roughness on a scale of 20–200 nm [root mean square (rms) value] serves to scatter the light, in order to increase the optical path of weakly absorbed light in the cell.[1–3] In combination with the light trapping effect in a medium (silicon) with a high index of refraction, it increases the current generated in thin-film silicon solar cells, leading to efficiencies over 14% in thin amorphous Si/microcrystalline Si tandem.[2,4]

Optical properties of thin-film silicon solar cells with nanorough interfaces were modeled.[5–7] These models ask for the accurate optical constants of materials used in the solar cells. They are well known for different forms of silicon (amorphous, microcrystalline, and crystalline) and ZnO with various doping levels,[5,8,9] but no precise spectral study has been done for the rough silver surface, covered by a thin ZnO layer—the best back reflector for thin-film silicon solar cells. A lower total reflectance of the rough metal surface compared to the smooth one was observed[1,5,10–12] but without a sufficient accuracy required, since a part of the scattered light is backreflected several times into the cell and, therefore, an error in the determination of the absorption losses accumulates.

In this article, we present the spectra of the total absorption loss (absorptance A) of nanorough silver surfaces measured with high accuracy. Instead of the measurement of the total reflectance R and calculation of $A = (1 - R)$, we measure A directly, using photothermal deflection spectroscopy (PDS). This helps us to increase the precision of measurement for the most important case of weak absorption losses (under 10%), as discussed below. The range 4–150 nm of rms roughness is covered. Roughness is determined by atomic force microscopy (AFM).

II. EXPERIMENTAL DETAILS

The PDS measurement[13] (Fig. 1) was done in CCl_4. Results were compared to the total reflectance measurement of a standard spectrometer. The PDS measurement requires a procedure for the absolute calibration of PDS data, which will be described below. This enables a very accurate measurement of A with an absolute error of about 0.5% which is one order of magnitude lower than can be reached with a spectrometer equipped by an integrating sphere (compare the error bars in Fig. 2 versus Figs. 4 and 5). We measure a PDS spectrum in the spectral range 0.8–4.5 eV (1550–276 nm). This provides a highly precise absorptance A spectrum over the entire region, however, on a relative scale.[13] In order to set this result into an absolute scale, we need to fix one point. We use the (bulk) plasma edge of silver at 316 nm, where the reflectance in air sharply drops below 1% (for a typical low spectral resolution, high light throughput PDS apparatus, it drops to 6%). This is a bulk effect, not affected by the surface roughness. This experimental value is in a good agreement (Fig. 2) with the one calculated, using the data of smooth bulk silver.[14] It yields the silver reflectance of 7% in CCl_4. Hence, we normalize our relative absorptance PDS data to be 93% at 316 nm (3.92 eV). The expected error of A resulting from this normalization is lower than an absolute error in the PDS spectrum.

Preparation of the nanotextured back reflectors involves three steps. First, the ZnO film was deposited on glass by sputtering. This film, initially "flat," [rms roughness < 15 nm, Fig. 3(a)] develops a surface texture upon etching in diluted HCl.[8,15,16] The surface roughness can be varied by varying the etching time. Such textured ZnO films were coated with 500 nm thick Ag films also prepared by sputtering. The surface texture of ZnO is maintained and thus the rms roughness of the Ag films in the range of 14–150 nm was reached (Fig. 3).

Our samples show a combination of the "flat" surface and etched craters. For the longest etching time of ZnO, the flat surface completely disappears. Additionally, we prepared
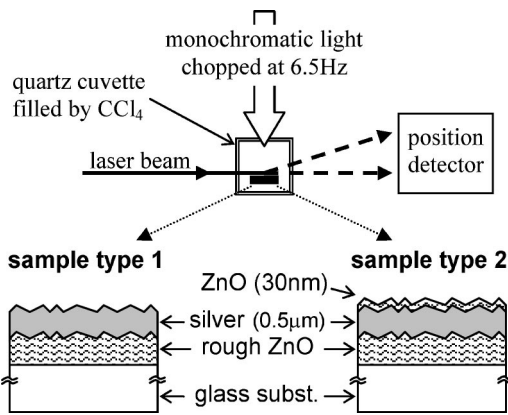
---

a)Electronic mail: springer@fzu.cz

FIG. 1. Experimental setup for PDS. Probe laser beam is periodically deflected due to the thermally induced refractive index gradient of CCl_4. Deflection angle is proportional to the total absorptance of sample. We measured two types of samples, sketched above.

two samples with a smooth silver surface as a reference: Silver sputtered directly on the Corning glass (rms roughness = 4.2 nm) and silver sputtered on a thin nonetched (30 nm) ZnO layer (rms roughness = 5.5 nm). Since the silver surface is sensitive to an ambient atmosphere, we kept the samples in the nitrogen atmosphere. Furthermore, the second series of samples was covered by 30 nm of ZnO (Fig. 1, sample type 2).

III. RESULTS

Experimental data obtained for both series are presented in Figs. 4–6. Our results show that the absorptance A (measured from the plasma edge in ultraviolet region down to the infrared) is not a simple function of the rms roughness. Back reflectors in silicon (amorphous and microcrystalline) solar cells operate between 500 and 1100 nm. The lowest absorption loss in this region is for the silver layer deposited directly on a glass substrate (Fig. 4, dashed line). Absorptance is already higher for silver deposited on an almost smooth (nonetched) ZnO layer independent of the surface rms roughness (5.5 nm and 14 nm) and increases for ZnO-etched
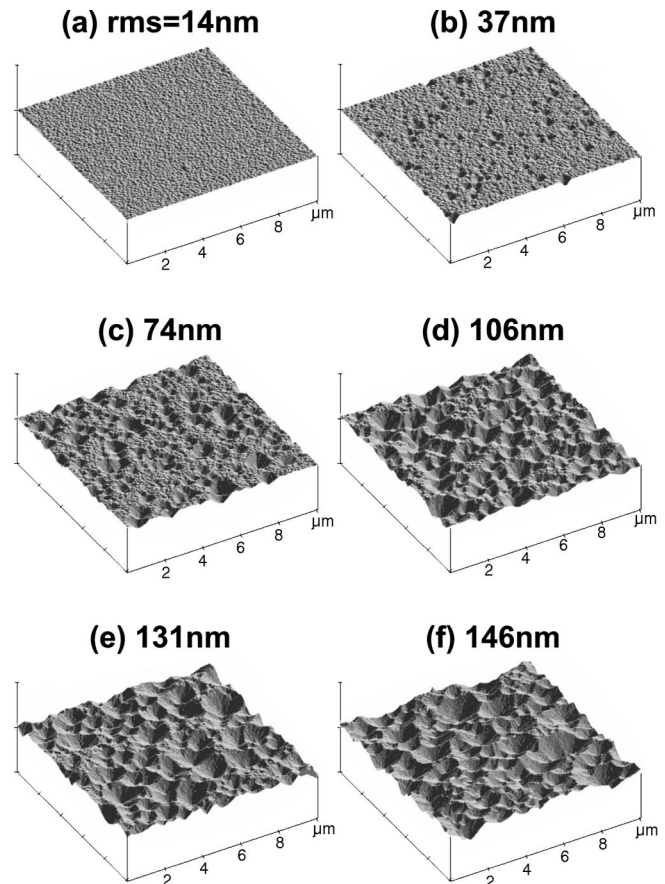

FIG. 3. AFM topography of silver surfaces deposited on smooth or rough ZnO (thickness 450–600 nm). The surface roughness was modified by varying etching time (see Refs. 7 and 15); the value of rms roughness is shown.

samples with craters (37–146 nm). A similar trend is for silver covered by 30 nm ZnO layer (Fig. 5). For the roughness larger than approximately 35 nm (rms), the absorptance saturates for both series (Fig. 6). The type of the sublayer is also important (compare Ag deposited on ZnO and glass with a similar shape and the rms roughness, Fig. 4 dashed lines).

We observe a shift in the position of the absorption peak. Figure 2 shows its position 3.5 eV for a Ag surface measured
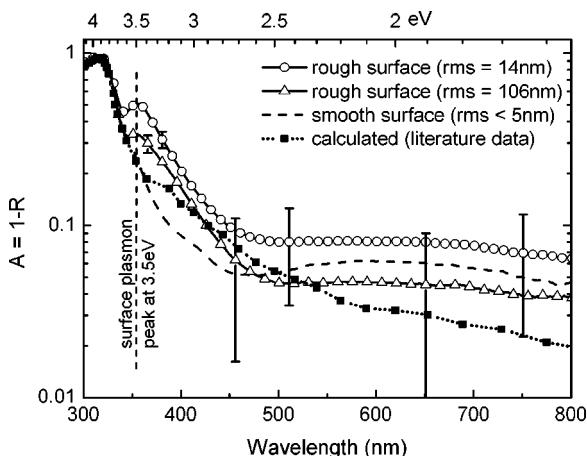

FIG. 2. Absorptance A of rough silver surface evaluated as $(1-R)$ from a spectrometer measurement with an integrating sphere. Expected relative error is 5% in the total reflectance R. The measurements are compared to the calculated values using literature data (see Ref. 13).
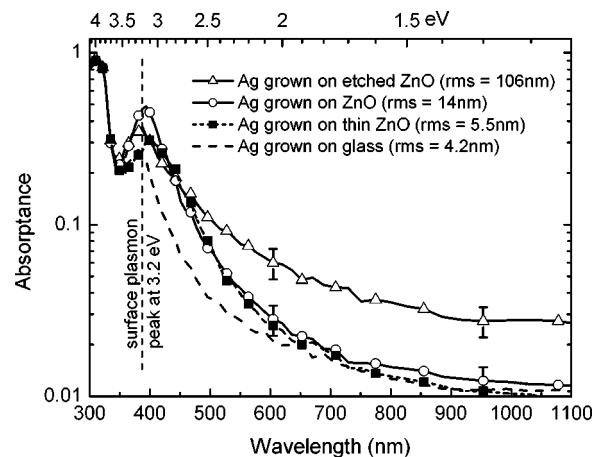
FIG. 4. Absorptance (A) spectra of rough silver surfaces as measured by PDS. Ag is in contact with CCl_4. Symbols show every third measured value. Expected relative error is 20% of the A.
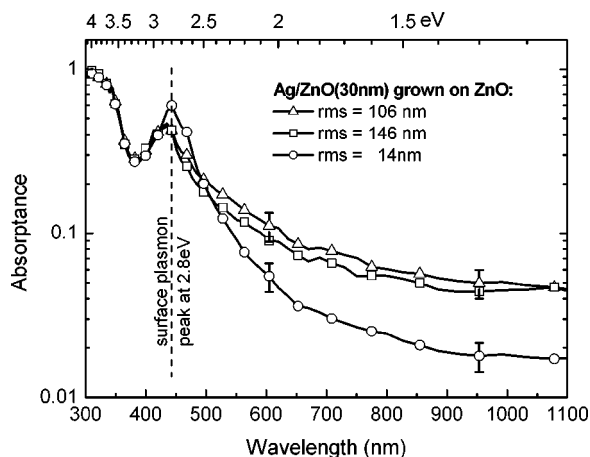
FIG. 5. Absorptance (*A*) spectra of rough silver surfaces covered by 30 nm ZnO (sample type 2), as measured by PDS. Symbols show every third measured value. Expected relative error is 20% of the *A*.

in air. The position moves to 3.2 and 2.8 eV for the PDS measurement of Ag and Ag/ZnO (30 nm) surface, respectively (Figs. 4 and 5). The peak is sharper for back reflectors deposited on nonetched ZnO (rms=14 nm) than on etched ZnO (rms>20 nm).

IV. DISCUSSION

We explain the measured data with the help of the surface plasmon (SP) theory.[17–19] An observed peak in absorption (dip in reflection) at about 320 nm corresponds to the (volume) plasma edge, another (weaker) resonance around 400 nm is due to the SP. This SP resonance moves toward the longer wavelengths when the dielectric, which is in contact with the rough Ag layer, has a higher index of refraction. This can be seen when comparing the peak position of the SP in Figs. 2, 4, and 5 where the corresponding refractive indexes of air, CCl_4, and ZnO are about 1, 1.5, and 2.1, respectively. This is just what should be expected for the SP resonance.[17] The case of low Ag surface roughness, below 10

nm, was already examined by Harbeke[18] who observed a resonant absorption (dip in reflection *R*) at 350 nm for the interface Ag/air.

Low absorption loss in spectral region 500–1100 nm is necessary for high efficiency of thin-film silicon solar cells. The broad SP peak increases absorption in this region. It can be influenced by the selection of dielectrics between the silicon absorber and silver and by the surface morphology. Further studies of optimal surface morphology to reduce losses, while keeping good light scattering properties of nanorough silver surface, are underway.

V. CONCLUSION

To conclude, we directly measured absorption losses in rough silver back reflectors, with a high precision in the spectral region of interest for thin-film silicon solar cells (500–1100 nm). Absorption loss did not scale directly with an increasing surface roughness and the saturation is observed. PDS as presented here proved to be a useful tool for this study.

[1] J. Morris, R. R. Arya, J. G. O'Down, and S. Wiedeman, J. Appl. Phys. **67**, 1079 (1990).
[2] A. V. Shah, H. Schade, M. Vanecek, J. Meier, E. Vallat-Sauvain, N. Wyrsch, U. Kroll, C. Droz, and U. Graf, Prog. Photovoltaics (to be published).
[3] A. Poruba, A. Fejfar, Z. Remes, J. Springer, M. Vanecek, J. Kocka, J. Meier, P. Torres, and A. Shah, J. Appl. Phys. **88**, 148 (2000).
[4] K. Yamamoto, A. Nakajima, M. Yoshimi, T. Sawada, S. Fukuda, K. Hayashi, T. Suezaki, M. Ichikawa, Y. Koi, M. Goto, H. Takata, and Y. Tawada, *Proceedings of the 29th IEEE PVSC, New Orleans, LA, (2002)*, p. 1110.
[5] J. Springer, A. Poruba, M. Vanecek, S. Fay, L. Feitknecht, N. Wyrsch, J. Meier, A. Shah, T. Repmann, O. Kluth, H. Stiebig, and B. Rech, *Proceedings of the 17th E-PVSEC, Munich, Germany (2002)*, p. 2830.
[6] J. Krc, M. Zeman, F. Smole, and M. Topic, J. Appl. Phys. **92**, 749 (2002).
[7] Y. Hishikawa, T. Kinoshita, M. Shima, M. Tanaka, S. Kiyama, S. Tsuda, and S. Nakano, *Proceedings of the 26th IEEE PVSC, Anaheim, CA, (1997)*, p. 615.
[8] O. Kluth, O. Vetterl, R. Carius, F. Finger, S. Wieder, B. Rech, and H. Wagner, Mater. Res. Soc. Symp. Proc. **557**, 731 (1999).
[9] J. Meier, J. Spitznagel, S. Fay, C. Bucher, U. Graf, U. Kroll, S. Dubail, and A. Shah, *Proceedings of the 29th IEEE PVSC, New Orleans, LA, (2002)*, p. 1118.
[10] H. Stiebig, T. Brammer, T. Repmann, O. Kluth, N. Senoussaoui, A. Lambertz, and H. Wagner, *Proceedings of the 16th E-PVSEC, Glasgow, UK, (2000)*, p. 549.
[11] A. Banerjee and S. Guha, J. Appl. Phys. **69**, 1030 (2002).
[12] X. Deng and K. L. Narasimhan, *Proceedings of the First WCPEC, Hawaii, (1994)*, p. 555.
[13] N. M. Amer and W. B. Jackson, in *Hydrogenated Amorphous Silicon Vol. 21, part B*, edited by J. I. Pankove, (Academic, Orlando, 1984), p. 83.
[14] D. W. Lynch and W. R. Hunter, in *Handbook of Optical Constants of Solids*, edited by E. D. Palik (Academic, Orlando, 1985), p. 350.
[15] B. Rech, O. Kluth, T. Repmann, T. Roschek, J. Springer, J. Müller, F. Finger, H. Stiebig, and H. Wagner, Solar Energy Mater. Solar Cells **74**, 439 (2002).
[16] O. Kluth, B. Rech, L. Houben, S. Wieder, G. Schöpe, C. Beneking, H. Wagner, A. Löffl, and H. W. Schock, Thin Solid Films **351**, 247 (1999).
[17] H. Raether, in *Surface Plasmons on Smooth and Rough Surfaces and on Gratings* Springer Tracts in Modern Physics Vol. 111, (Springer, Berlin, 1988).
[18] G. Harbeke, in *Polycrystalline Semiconductors*, edited by G. Harbeke (Springer, Berlin, 1985), p. 156.
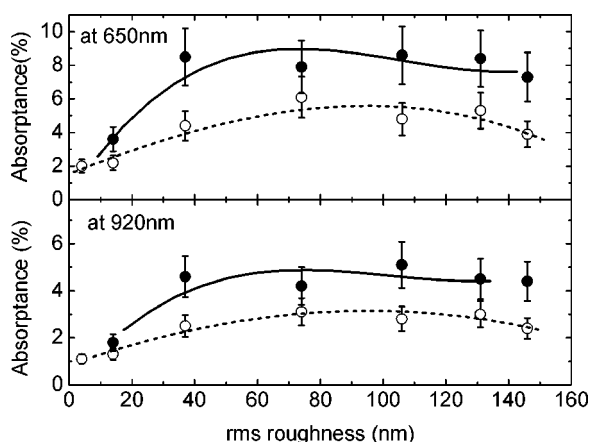[19] E. Fontana and R. H. Pantell, Phys. Rev. B **37**, 3164 (1988).

FIG. 6. Summary of absorptance values for rough ZnO/Ag surfaces (full symbols) and Ag surfaces (open symbols) at 650 and 920 nm, as a function of the surface roughness.